



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

TOSHIMA, *et al.*

Serial No.: 10/052,534

Filed: January 23, 2002

For: SUBSTRATE PROCESSING APPARATUS AND  
SUBSTRATE PROCESSING METHOD

Art Unit: 1746

Examiner: Kornakov, Michail

Atty. Dckt: 033082M115

**RESPONSE AS SUBMISSION UNDER 37 C.F.R. § 1.114 WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Mail Stop: Amendment**

Dear Sir:

This is in response to the Office Action mailed July 12, 2006, to which the time for response was set to expire October 12, 2006. A Petition for a Three-Month Extension of Time and the requisite fee are submitted herewith to extend the due date to January 12, 2007. This paper is part of the "submission" with a Request for Continued Examination (RCE) filed concurrently herewith. Claims 1-19 and 35 will remain pending. Claims 1-9 and 35 were rejected. Claims 10-19 are withdrawn. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper.  
Remarks begin on page 9 of this paper.